

Abstract Submitted
for the MAR07 Meeting of
The American Physical Society

Preparation of Dilute Magnetic Oxide Thin Films by Reactive-Biased Target-Ion Beam-Sputter Deposition KEVIN G. WEST, JIWEI LU, JIANI YU, WEI CHEN, YONGHANG PEI, LI HE, STUART A. WOLF, University of Virginia — We have used reactive-biased target-ion beam-sputter deposition to prepare $\text{Co}_x\text{Ti}_{1-x}\text{O}_2$ thin films on LaAlO_3 (100) and SrTiO_3 (100) substrates for $0.005 < x < 0.06$. The influence of the growth parameters on the microstructure, magnetic and transport properties of $\text{Co}_x\text{Ti}_{1-x}\text{O}_2$ was systematically investigated. Both pure anatase phase and mixed anatase/rutile phases of TiO_2 films were obtained by varying the growth conditions and subsequently demonstrated different magnetic and transport properties. All samples show a curie temperature higher than 300 K. The pure anatase $\text{Co}_x\text{Ti}_{1-x}\text{O}_2$ thin films have saturated magnetic moments of $1\sim 2 \mu_B/\text{Co}$ at 10 K. The presence of rutile phase seems to greatly enhance the moments at lower temperatures.

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Date submitted: 18 Nov 2006

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